11/30/2006 15:03

===	COVER	SHEET	===

TO: _____

FROM:

MCKENNA LONG ALDRIDG

FAX#: 202-496-7756

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COMMENT:

PAGE 1/9 * RCVD AT 11/30/2006 3:03:09 PM [Eastern Standard Time] * SVR:USPTO-EFXRF-5/6 * DNIS:2731389 * CSID:202 496 7756 * DURATION (mm-ss):01-26

McKenna Long & Aldridge LLP 1900 K Street, NW Washington, D.C. 20006 Voice: (202) 496-7500

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Date: November 30, 2006

To:

Name/Company	Fax No.	Phone No.
Examiner Stephen D. Rosasco	(571) 273-1389	(571) 272-1389
U.S. Patent and Trademark Office (Art Unit 1756)		

From:

Jeanne A. Di Grazio/es

Phone: (202) 496-7309

Re:

U.S. Application Serial No. 10/705,891

Number of Pages (including cover): 8

Message:

U.S. Application Serial No. 10/705,891

Filed: November 13, 2003

Title: MASK FOR LASER IRRADIATION AND APPARATUS FOR LASER

CRYSTALLIZATION USING THE SAME

Inventor(s): Yun Ho JUNG

Examiner Rosasco:

Per our previous telephone call, please find the attached courtesy copy of the Supplemental Amendment which was filed today in connection with the above referenced application.

User No.

4091

Client/Matter No.:

08734.0254

If transmission is unclear or incomplete, please call sender at the above phone number.

Docket No.: 8734.254.00-US

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yun Ho JUNG

Customer No.: 30827

Application No.: 10/705,891

Confirmation No.: 6104

Filed: November 13, 2003

Art Unit: 1756

For: MASK FOR LASER IRRADIATION AND

APPARATUS FOR LASER

CRYSTALLIZATION USING THE SAME

Examiner: Stephen D. Rosasco

MS Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUPPLEMENTAL AMENDMENT

Sir:

Further to the Amendment filed on October 27, 2006 in response to the Office Action dated July 28, 2006, please amend the above-identified Patent Application as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.